

Form PTO-1595 (Rev. 07/05)
OMB No. 0651-0027 (exp. 6/30/2008)

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Name: United States Department of Energy

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4. Application or patent number(s):

A. Patent Application No.(s)

13/570,556

☐ This document is being filed together with a new application.

B. Patent No.(s)

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5. Name and address to whom correspondence concerning document should be mailed:

Name: Mark P. Dvorscak

Internal Address: U. S. Dept. of Energy, IPLD

Street Address: 9800 S. Cass Ave

City: Argonne

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6. Total number of applications and patents involved: 1**7. Total fee (37 CFR 1.21(h) & 3.41) \$ _____**

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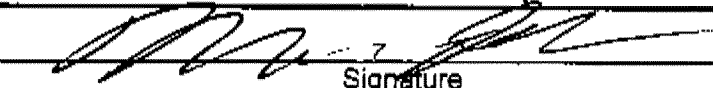
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PATENT

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Invention Title: Contact-Independent and High-Resistance Measurement of Electrical Conductance of a Thin Solid Film with a Nanoscale

Inventor(s): Marc A. Kastner, Tamar Mentzel, Kenneth MacLean, Nirat Ray

U.S. Filing/Issue Date: 08/09/2012

Patent or Application Serial No.: 13/570,556

Grant/Contract Number(s): DE-FG02-08ER46515, W911NF-07-D-0004

Foreign Applications filed/intended in (countries): _____

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By Rolande Johndro
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Title Patent Compliance Administrator

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